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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph A. Wasshuber

Art Unit: 2818

Serial No.: 10/714,366

Examiner: Nguyen, T.

Filing Date: 11/13/2003

Docket No.: TI-36280

Customer No.: 23494

Conf. No.: 1864

Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH PROCESSES

ELECTION**MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(A)**

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as first Class Mail in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

Date

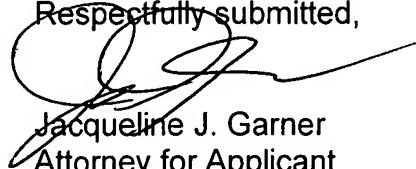
Marianna Smith

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

With respect to the Restriction Requirement mailed on 02/07/2005, the Examiner has restricted the instant application to the invention of Group I (Claims 1-11), or Group II (Claims 12-20). In light of this, Applicant elects to pursue Group I, (Claims 1-11) without traverse.

Respectfully submitted,

  
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